

Electronic Patent Application Fee Transmittal

Application Number:	10763588			
Filing Date:	23-Jan-2004			
Title of Invention:	PENDEOEPIITAXIAL METHODS OF FABRICATING GALLIUM NITRIDE SEMICONDUCTOR LAYERS ON SAPPHIRE SUBSTRATES, AND GALLIUM NITRIDE SEMICONDUCTOR STRUCTURES FABRICATED THEREBY			
First Named Inventor/Applicant Name:	Thomas Gehrke			
Filer:	Steven Phillips/Patricia Pontello			
Attorney Docket Number:	013921-000026			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appt Issue fee	1501	1	1400	1400
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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